

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Christian Kratzsch et al.

Serial No.: 09/807,061

Filing Date: 07/09/2001

Title: METHOD FOR SHAPING MATERIALS WITH

PLASMA-INDUCING HIGH-ENERGY RADIATION

Group Art Unit: 2853

Examiner: Blaise L. Mouttet

Attorney's Docket No.: STUR-35

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

## PETITION FOR AUTOMATIC EXTENSION OF TIME TO RESPOND

Applicants hereby petition for a three (3) month extension of time to respond to the outstanding OFFICE ACTION mailed January 27, 2004, with respect to the above-identified patent application, thereby extending the time for response from April 27, 2004 to July 27, 2004.

A check in the amount of \$475.00 is enclosed to cover the cost of the petition fee. This petition fee has been calculated on the basis of a Small Entity status.

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In the event that any additional fees may be required to be paid in connection with this matter, please charge the same, or credit any overpayment, to Deposit Account No. 16-0221. A duplicate copy of this Petition is enclosed for the convenience of the Office.

Thank you.

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL, POSTAGE PREPAID, IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450, ON:

July 6, 2004
(DATE OF DEPOSIT)

Scott R. Foster

(SIGNATURE)

July 6, 2004

(DATE OF SIGNATURE)

Respectfully submitted,

Scott R. Foster

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